

10-09-0A

6P2813



Filed Via Express Mail  
Rec. No.: EL 902 035 934 US  
On: OCTOBER 5, 2001  
By: *Linda Hastings*  
LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an  
enclosed check, may be charged on Deposit Acct. No. 50-1290.

#6/Elections  
*Linda Hastings* signed  
10/12/01

Attorney Docket No.: NECK 17.552

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

RECEIVED  
TC 2800 MAIL ROOM  
OCT 11 2001

Inventor: Hiroshi TANABE  
Serial No.: 09/614,286  
Filed: July 12, 2000  
Title: **METHOD FOR FORMING SEMICONDUCTOR FILMS  
AT DESIRED POSITIONS ON A SUBSTRATE**  
Examiner: Timothy J. Sutton  
Group Art Unit: 2813

Assistant Commissioner for Patents  
Washington, D.C. 20231

**ELECTION**

SIR:

In response to the Office Action mailed on September 10, 2001, the period for responding thereto having been set to expire after October 10, 2001, Applicant hereby elects Group I, claims 1-10, for prosecution at this time. Applicant reserves the right to file a continuing application based on claims 11-14. Early examination on the merits is earnestly solicited.

Any fee due with this paper, not fully covered by an enclosed check, may be charged on

Deposit Account 50-1290.

Respectfully submitted,



Michael I. Markowitz  
Reg. No. 30,659

ROSENMAN & COLIN LLP  
575 MADISON AVENUE  
NEW YORK, NEW YORK 10022  
(212) 940-8800  
DOCKET NO.: NECK 17.552

SH:MIM:lh:NECK17552